Special Issue

Challenges in Machine Learning, Artificial Intelligence, Wireless Sensor Networks and Smart Cities

Message from the Guest Editors

This Special Issue encourages original and high-quality submissions, with both applied and theoretical research approaches, related (but not limited) to the following topics:

- Machine learning;
- Deep learning;
- Artificial intelligence;
- Smart cities;
- Internet of Things;
- Wireless sensor networks;
- Visual analytics;
- Ambient intelligence;
- Robotics;
- Natural language processing.

Guest Editors

Dr. Pablo Chamoso

Dr. Guillermo Hernández

Prof. Dr. Paulo Novais

Deadline for manuscript submissions

closed (30 November 2022)



Processes

an Open Access Journal by MDPI

Impact Factor 2.8 CiteScore 5.5



mdpi.com/si/75758

Processes
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland

processes@mdpi.com mdpi.com/journal/

Tel: +41 61 683 77 34

processes





Processes

an Open Access Journal by MDPI

Impact Factor 2.8 CiteScore 5.5



About the Journal

Message from the Editor-in-Chief

You are invited to contribute either a research article or a comprehensive review for consideration and publication in *Processes* (ISSN 2227-9717). *Processes* is published in open access format – research articles, reviews, and other content are released on the internet immediately after acceptance. The scientific community and the general public have unlimited, free access to the content. As an open access journal, *Processes* is supported by the authors and their institutes through the payment of article processing charges (APCs) for accepted papers. We would be pleased to welcome you as one of our authors.

Editor-in-Chief

Prof. Dr. Giancarlo Cravotto

Department of Drug Science and Technology, University of Turin, Via P. Giuria 9, 10125 Turin, Italy

Author Benefits

Open Access:

free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility:

indexed within Scopus, SCIE (Web of Science), Ei Compendex, Inspec, AGRIS, and other databases.

Journal Rank:

CiteScore - Q2 (Chemical Engineering (miscellaneous))

